

DPW

Attorney Docket No.: 0492611-0545/MIT-9277CONII

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE


Applicant: Seleznev, et al. Examiner: Cooke
Serial No.: 10/799,388 Art Unit: 1754
Filing Date: March 12, 2004

Title: VACUUM PROCESSING FOR FABRICATION OF
SUPERCONDUCTING THIN FILMS FABRICATED BY METAL-
ORGANIC PROCESSING

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450
Sir:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on June 3, 2005.


Susan M. Dinsmore


TRANSMITTAL

Enclosed herewith please find:

- 1) Supplemental Office Action Response Under 37 C.F.R. §1.111 (6 pgs.);
- 2) Statement Filed Pursuant to the Duty of Disclosure Under 37 C.F.R. §1.56, 1.97 and 1.98 (5 pgs.);
- 3) Form PTO-1449 (4 pgs.);
- 4) Cited art;
- 5) Check in the amount of \$180.00; and
- 6) Return postcard.

Please charge any fees associated with this filing, or apply any credits, to our Deposit Account No. 03-1721.

Respectfully submitted,


Valarie B. Rosen, Ph.D.
Registration Number 45,698

Choate, Hall & Stewart LLP
Exchange Place
53 State Street
Boston, MA 02109
(617) 248-5000
Dated: June 3, 2005